

AMENDMENT TRANSMITTAL LETTER				Docket No. 3430-0131P
Application No. 09/648,111	Filing Date August 25, 2000	Examiner A. R. Wilson		Art Unit 2815
Applicant(s): Kwang-Jo HWANG				
Invention: METHOD OF PATTERNING A METAL LAYER IN A SEMICONDUCTOR DEVICE				
MS RCE Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450				
Transmitted herewith is an amendment in the above-identified application.				
The fee has been calculated and is transmitted as shown below.				
CLAIMS AS AMENDED				
	Claims Remaining After Amendment	Highest Number Previously Paid	Number Extra Claims Present	Rate
Total Claims	26	- 30 =		x
Independent Claims	4	- 4 =		x
Multiple Dependent Claims (check if applicable) <input type="checkbox"/>				
Other fee (please specify): Request for continued examination (RCE) (see 37 CFR 1.114)				810.00
TOTAL ADDITIONAL FEE FOR THIS AMENDMENT:				810.00
<input checked="" type="checkbox"/> Large Entity <input type="checkbox"/> Small Entity				
<input type="checkbox"/> No additional fee is required for this amendment.				
<input checked="" type="checkbox"/> Please charge Deposit Account No. 02-2448 in the amount of \$ 810.00 A duplicate copy of this sheet is enclosed.				
<input type="checkbox"/> A check in the amount of \$ _____ is enclosed.				
<input type="checkbox"/> Payment by credit card. Form PTO-2038 is attached.				
<input checked="" type="checkbox"/> The Director is hereby authorized to charge and credit Deposit Account No. 02-2448 as described below. A duplicate copy of this sheet is enclosed.				
<input checked="" type="checkbox"/> Credit any overpayment.				
<input checked="" type="checkbox"/> Charge any additional filing or application processing fees required under 37 CFR 1.16 and 1.17.				
Esther Chong			Dated: January 12, 2009	
Esther H. Chong Attorney Reg. No.: 40,953				
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